



PATENT
Attorney Docket No. 04173.0441

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Hisashi Kaneko et al.) Group Art Unit: 2123
)
Application No.: 10/757,415) Examiner: SHARON, Ayal I.
)
Filed: January 15, 2004) Confirmation No.: 3384
)
For: SIMULATION CIRCUIT PATTERN)
EVALUATION METHOD,)
MANUFACTURING METHOD OF)
SEMICONDUCTOR INTEGRATED)
CIRCUIT, TEST SUBSTRATE,)
AND TEST SUBSTRATE GROUP)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed December 19, 2006, the period to respond to which extending through March 19, 2007, Applicants request reconsideration in view of the following:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.